



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Yi-Ming Sheu

Serial No.: 10/619,114

Filed: 07/14/2003

For: NARROW WIDTH EFFECT
IMPROVEMENT WITH PHOTORESIST PLUG
PROCESS AND STI CORNER ION
IMPLANTATION

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)
) Group Art Unit: 2823

)
) Examiner: Brewster, William

)
) Confirmation No.: 6852

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) TKHR Docket: 252016-1300

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) Top-Team Dkt: 0503-9540US
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Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop Amendment; Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on February 25, 2005.


Signature - Hui Chin Barnhill

ENTER
W/ RCE
FILED 4/6/05

AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

The Office Action mailed December 23, 2004 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.